

PATENT ASSIGNMENT

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SUBMISSION TYPE:

NEW ASSIGNMENT

NATURE OF CONVEYANCE:

ASSIGNMENT

CONVEYING PARTY DATA

Name	Execution Date
Konstantin BOURDELLE	02/20/2007
Nicolas DAVAL	02/12/2007
Ian CAYREFOURCQ	02/16/2007
Steven R. A. VAN AERDE	02/07/2007
Marinus J. DE BLANK	02/22/2007
Cornelius A. VAN DER JEUGD	02/07/2007

RECEIVING PARTY DATA

Name:	S.O.I.TEC SILICON ON INSULATOR TECHNOLOGIES S.A.
Street Address:	Parc Technologique des Fontaines
Internal Address:	Chemin des Franques
City:	Bernin
State/Country:	FRANCE
Postal Code:	38190

Name:	ASM INTERNATIONAL
Street Address:	Jan Van Eijcklaan 10
City:	BC Bilthoven
State/Country:	NETHERLANDS
Postal Code:	3723

PROPERTY NUMBERS Total: 1

Property Type	Number
Application Number:	11677696

CORRESPONDENCE DATA

Fax Number: (212)294-4700

Correspondence will be sent via US Mail when the fax attempt is unsuccessful.

PATENT

500242091

REEL: 019032 FRAME: 0965

CH \$40.00 11677696

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Address Line 4:	Washington, DISTRICT OF COLUMBIA 200063817

ATTORNEY DOCKET NUMBER:	4717-22100
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NAME OF SUBMITTER:	ALLAN A. FANUCCI
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Total Attachments: 4

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ASSIGNMENT

WHEREAS, each of

Konstantin BOURDELLE, a citizen of Russia, residing at,
22, rue du Luiset, F-38930 Crolles, France;

Nicolas DAVAL, a citizen of France, residing at,
15, Boulevard Maréchal, Leclerc, F-38000 Grenoble, France;

Ian CAYREFOURCQ, a citizen of France, residing at,
74, Chemin de Theys, F-38330 Saint Nazaire les Eymes, France;

Steven R. A. VAN AERDE, a citizen of Belgium, residing at,
Oude Leuvenseban 16, B-3390 Tielt-Winge, Belgium;

Marinus J. DE BLANK, a citizen of the Netherlands, residing at,
Van Ostaijenlaan 39, B-3001 Heverlee, Belgium; and

Cornelius A. VAN DER JEUGD, a citizen of the Netherlands,
residing at Dreefstraat 6, B-3001 Heverlee, Belgium.

an ASSIGNOR, is an inventor of the invention in **METHOD OF MANUFACTURING A SILICON DIOXIDE LAYER**, for which an application for a Patent of the United States, identified by Winston & Strawn LLP Docket No. **4717-22100**.

- ☐ is executed on even date herewith.
☒ was filed on 02/22/2007 as Application No. 11/677,696.

WHEREAS, **S.O.I.TEC SILICON ON INSULATOR TECHNOLOGIES S.A.**, a French corporate body having a place of business at Parc Technologique des Fontaines, F-38190 Bernin, France, and **ASM INTERNATIONAL**, having a place of business at Jan Van Eijcklaan 10, 3723 BC Bilthoven, The Netherlands, ASSIGNEES, are desirous of jointly obtaining each inventor's entire right, title and interest in, to and under the said invention, the said application and corresponding applications worldwide.

NOW, THEREFORE, in exchange for good and valuable consideration to each inventor, the receipt and sufficiency of which is hereby acknowledged, each ASSIGNOR has sold, assigned, transferred and set over, and by these presents does hereby sell, assign, transfer and set over, unto the said ASSIGNEES, their successors, legal representatives and assigns, his or her entire right, title and interest in, to and under the invention, and any United States provisional or non-provisional application embodying the invention or any other United States application claiming priority to a provisional application under 35 U.S.C. § 119(e) or converted therefrom, or to any application claiming the benefit of a non-provisional application under 35 U.S.C. § 120, including all divisions, continuations, and continuations-in-part thereof, and all Patents of the United States which may be granted thereon and all reissues and extensions thereof;

And each ASSIGNOR hereby authorizes and requests the Commissioner of Patents and Trademarks of the United States, and any Official of any country or countries foreign to the United States, whose duty it is to issue patents or other evidence or forms of industrial property protection on applications as aforesaid, to issue the same to the ASSIGNEES, their successors, legal representatives and assigns, in accordance with the terms of this instrument;

And each ASSIGNOR hereby covenants and agrees that he or she has the full right to convey the entire interest herein assigned, and that he or she has not executed, and will not execute, any agreement in conflict herewith;

And each ASSIGNOR hereby further covenants and agrees that he or she will communicate to the ASSIGNEES, their successors, legal representatives and assigns, any facts known to him or her respecting said invention, testify in any legal proceeding, sign all lawful papers, execute all divisional, continuing, reissue and foreign applications, make all rightful oaths, and generally do everything possible to aid the ASSIGNEES or, their successors, legal representatives and assigns, to obtain and enforce proper protection for said invention in all countries;

And each ASSIGNOR hereby authorizes the ASSIGNEES' patent attorney to complete this form by the addition of the application number, application filing date, and attorney docket number, if necessary.

In witness whereof, each inventor has affixed his or her signature.

20/02/2007
Date

Konstantin BOURDELLE
Konstantin BOURDELLE

On this 20th day of February, 2007, before me appeared **Konstantin BOURDELLE**, to me known and known to me to be the person of that name, who signed the foregoing instrument, and acknowledged the same to be his/her free act and deed.

Andrzej Huzar
Witness *Andrzej Huzar*

2007-02-12
Date

Nicolas DAVAL
Nicolas DAVAL

On this 12th day of February, 2007, before me appeared **Nicolas DAVAL**, to me known and known to me to be the person of that name, who signed the foregoing instrument, and acknowledged the same to be his/her free act and deed.

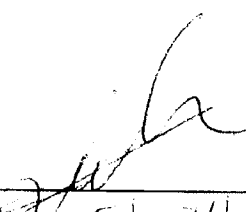
Andrzej Huzar
Witness *Andrzej Huzar*
ASSISTANT IP

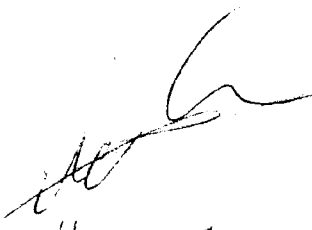
16/02/2007
Date

Ian CAYREFOURCQ
Ian CAYREFOURCQ

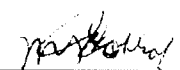
On this 16th day of February, 2007, before me appeared **Ian CAYREFOURCQ**, to me known and known to me to be the person of that name, who signed the foregoing instrument, and acknowledged the same to be his/her free act and deed.

Andrzej Huzar, ASSISTANT IP
Witness *Andrzej Huzar*



Date Febr. 7th, 2007


Febr. 7th, 2007
Steven R. A. VAN AERDE

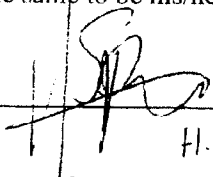
On this 7th day of FEBRUARY, 2007, before me appeared **Steven R. A. VAN AERDE**, to me known and known to me to be the person of that name, who signed the foregoing instrument, and acknowledged the same to be his/her free act and deed.


Witness

Febr. 7th, 2007
Date


Marinus J. DE BLANK

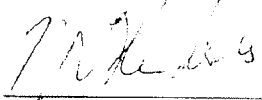
On this 7th day of February, 2007, before me appeared **Marinus J. DE BLANK**, to me known and known to me to be the person of that name, who signed the foregoing instrument, and acknowledged the same to be his/her free act and deed.

Witness 
H. SPREY

Febr. 7th 2007
Date


Cornelius A. VAN DER JEUGD

On this 7th day of February, 2007, before me appeared **Cornelius A. VAN DER JEUGD**, to me known and known to me to be the person of that name, who signed the foregoing instrument, and acknowledged the same to be his/her free act and deed.


Witness M. HENDRIKS